

PATENT APPLICATION
Docket No. 9898-314
Client No. SS-20035-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Won-Jun Lee, et al.

Serial No.: 10/763,356 Examiner: Alanko, Anita Karen

Filed: January 23, 2004 Art Unit: 1765

Conformation No. 7097

For: ETCHING METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

☐ under 37 CFR 1.97 (b); or
(Within three months of filing national application; or date of entry of
International application; or before mailing date of first office action on the
merits; or before the mailing of a first Office Action after the filing of a request
for continued examination under §1.114; whichever occurs last)

☒ under 37 CFR 1.97 (c) together with either a:
☒ Statement under 37 CFR 1.97 (e), or
☐ a \$180 fee under 37 CFR 1.17 (p); or
(After mailing of first Office Action, but prior to Notice of Allowance or Final

Office Action)

☐ under 37 CFR 1.97 (d) together with:
☐ Statement under 37 CFR 1.97 (e), and
☐ a \$180.00 fee set forth in 37 CFR 1.17 (p).

(Filed after final action or notice of allowance, whichever occurs first, but
before payment of the issue fee)

☒ Applicant(s) submit herewith Form PTO 1449- Information Disclosure Citation
together with copies of patents, publications or other information of which applicant(s) are
aware, which applicant(s) believe(s) may be material to the examination of this application and
for which there may be a duty to disclose in accordance with 37 CFR 1.56.

It is requested that the information disclosed herein be made of record in this
application.

Any deficiency or overpayment should be charged or credited to deposit account number 13-1703. A duplicate copy of this sheet is enclosed.

Customer No. 20575

Respectfully submitted,

MARGER JOHNSON & McCOLLOM, P.C.



Hosoon Lee
Reg. No. 56,737

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INFORMATION DISCLOSURE CITATION
FORM PTO-1449 (Modified)U.S. PATENT DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Issue</u> <u>Date</u>	<u>Name</u>	<u>Class</u>	<u>Sub</u> <u>Class</u>
_____	_____					

FOREIGN PATENT DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Document</u> <u>Number</u>	<u>Publication</u> <u>Date</u>	<u>Country</u>	<u>Name</u>
_____	_____	0595360 A1	May 4, 94	Europe	Saeki, Takanori
_____	_____	DE4307725	Sep. 16, 93	Germany	Dennison Charles H. et al.
_____	_____	DE4412086	Oct. 13, 94	Germany	Tae-Hyuk AHN. et al.

OTHER DOCUMENTS

<u>Exam</u> <u>Init</u>	<u>Ref</u>	<u>Author, Title, Date, Pertinent Pages, Etc.)</u>
_____	_____	English language abstract of German Publication No. DE4307725
_____	_____	English language abstract of German Publication No. DE4412086

Examiner: _____

Date Considered: _____

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450STATEMENT ON FILING INFORMATION DISCLOSURE STATEMENT
(37 CFR 1.97(c))

I, Hosoon Lee, the person signing below state that:
each item of information contained in the Information Disclosure Statement submitted
herewith was first cited in a communication from a foreign patent office in a counterpart
foreign application not more than three months prior to the filing of this Statement

Applicant respectfully requests consideration of the accompanying Information
Disclosure Statement.

The person making this Statement is the attorney who signs below on the basis of the
information in the attorney's file.

Respectfully submitted,
MARGER JOHNSON & McCOLLOM, P.C.



Hosoon Lee
Reg. No. 56,737

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I hereby certify that this correspondence is
being transmitted to the U.S. Patent and
Trademark Office via facsimile number 571-
273-8300, on March 24, 2006.


Li Mei Vermilya